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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>						Complete if Known	
				Application Number		09/986,743	
				Filing Date		November 9, 2001	
				First Named Inventor		Shunpei YAMAZAKI et al.	
				Group Art Unit		2812	
				Examiner Name		A. Ghyka	
Sheet	1	of	1	Attorney Docket Number		0756-2378	

[illegible]

FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ²	Number ⁴	Kind Code ³ (if known)				
AL		JP	10-062355			03/06/1998		Abst.
		JP	10-064842			03/06/1998		Abst.
		JP	05-082466			04/02/1993		Abst.
		JP	06-291034			10/18/1994		Abst.
		JP	08-051077			02/20/1996		Abst.

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AE		Office Action dated April 8, 2005 from Patent Office of the People's Republic of China, for Application No. 00122783.1.	
AG		R. DASSOW et al., <i>Laser-Crystallized Polycrystalline Silicon on Glass for Photovoltaic Applications</i> , Solid State Phenomena, April, 1999, Vol. 67-8, Pages 193-197 (Abstract) (1 page).	

Examiner Signature	<i>[Signature]</i>	Date Considered	7/27/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.